

1080 U.S.
10/02437
12/31/01

3c/900

P

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10024373	12/21/2001	430	270.1	1752	ASH TON

****APPLICANTS:** Takechi Satoshi; Takahashi Makoto; Kaimoto Yuko;

****CONTINUING DATA VERIFIED:**

THIS APPLICATION IS A DIV OF 09/438,416 11/12/1999 PAT 6,344,304
WHICH IS A DIV OF 08/999,394 12/29/1997 PAT 6,004,720
WHICH IS A CON OF 08/365,407 12/28/1994 ABN

BEST AVAILABLE COPY

**** FOREIGN APPLICATIONS VERIFIED:**

JAPAN 05-337434/1993 12/28/1993

PG-PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no

Verified and Acknowledged Examiners's initials

ATTORNEY DOCKET NO

108077-00001

TITLE : Radiation sensitive material and method for forming pattern

U.S. DEPT. OF COMM./PAT & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED		
			Total Claims	Print Claim for O.G	
ISSUE FEE		Primary Examiner	DRAWING		
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner		
		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.			

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)